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**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Confirmation No.: 9442

Hiroya KIRIMURA et al.

Art Unit: 1722

Application No.: 09/822,414

Examiner: M. Song

Filed: April 2, 2001

Attorney Dkt. No.: 107351-00011

For: FILM FORMING APPARATUS AND METHOD OF FORMING A  
CRYSTALLINE SILICON FILM

**RESPONSE TO FINAL REJECTION UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

November 8, 2006

Sir:

In reply to the Office Action dated August 8, 2006, please consider the following remarks.

The pending claims begin on page 2.

Remarks begin on page 13.

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